IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

FEB 19 2002

Atty. Docket No. (Opt.) **XDEV1100**

TECHILLE Applicant

Martin E. Kordesch et al.

Application Number

09/682,151

July 27, 2001

Filed

For

Contact Method for Thin Silicon Carbide Epitaxial Layer and Semiconductor Devices Formed by

Those Methods

Group Art Unit

Examiner Unknown

2811

Certification Under 37 C.F.R. §1.8

Assistant Commissioner for Patents Washington, D.C. 20231

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olvn Williams

Applicants respectfully request, pursuant to 37 C.F.R. §§ 1.56, 1.97 and 1.98, that the art listed on the attached PTO-1449 form be considered and cited in the examination of the aboveidentified application. A copy of the art is enclosed for the convenience of the Examiner. Furthermore, pursuant to 37 C.F.R. §§ 1.97(g) and (h), no representation is made that a search has been made or that this art is material to patentability of the present application.

While Applicants believe no fees are due, if any fees are due, the Commissioner is hereby authorized to charge Deposit Account No. 50-0456 of Gray Cary Ware & Freidenrich LLP.

Applicants respectfully submit that the claims of Applicants' above-referenced patent application are patentably distinguishable from these references.

Respectfully submitted.

Gray Cary Ware & Freidenrich LLP

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